

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

DECLARATION FOR PATENT APPLICATION

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am an original, first and joint inventor of the subject matter which is claimed and for which a patent is sought on the invention entitled:

ATOMIC LAYER DOPING APPARATUS AND METHOD

The specification of which was filed on August 31, 2000 and assigned serial number 09/653,553.

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by an amendment, if any, specifically referred to in this oath or declaration.

I acknowledge the duty to disclose all information known to me which is material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56.

I hereby claim foreign priority benefits under Title 35, United States Code § 119/365 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

Prior Foreign Application(s)

Priority  
Not  
Claimed

_____ (Number)	_____ (Country)	_____ (Filing Date)	<input type="checkbox"/>
_____ (Number)	_____ (Country)	_____ (Filing Date)	<input type="checkbox"/>
_____ (Number)	_____ (Country)	_____ (Filing Date)	<input type="checkbox"/>

[illegible]

(Status)  
(patented, pending, abandoned)

Post Office Address: 2964 East Parkriver Drive  
Boise, Idaho 83706

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
DECLARATION FOR PATENT APPLICATION

Signature Page for Second Inventor

Full name of second inventor: Trung T. Doan

Inventor's signature:



Date: 11-20-00

Residence: Boise, ID

Citizenship: United States of America

Post Office Address: 1574 Shenandoah Drive  
Boise, Idaho 83712

00000000 15000000

Docket No.: M4065.0353/P353  
(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

---

In re Patent Application of:  
Gurtej Sandhu, et al.

Serial No.: 09/653,553

Group Art Unit: 1762

Filed: August 31, 2000

Examiner: Not Yet Assigned

---

For: ATOMIC LAYER DOPING APPARATUS  
AND METHOD

---

**POWER OF ATTORNEY BY ASSIGNEE AND  
CERTIFICATE BY ASSIGNEE UNDER 37 CFR § 3.73(B)**

Assistant Commissioner for Patents  
Washington, DC 20231

Dear Sir:

Micron Technology, Inc., Assignee of the entire right, title and interest in the above-identified application by virtue of the Assignment attached hereto (which is also being submitted concurrently for recordation), hereby appoints the attorneys and agents of the firm of Dickstein Shapiro Morin & Oshinsky LLP located at 2101 L Street NW, Washington, DC 20037-1526, listed as follows:

Gary M. Hoffman	26,411	Eric Oliver	35,307	Mark E. Strickland	45,138
Thomas J. D'Amico	28,371	Laurence E. Fisher	37,131	Salvatore P. Tamburo	45,153
Donald A. Gregory	28,954	William E. Powell, III	39,803	Peter Veytsman	45,920
James W. Brady, Jr.	32,115	Jeremy A. Cubert	40,399	Donald L. Bowman	46,432
Jon D. Grossman	32,699	Gianni Minutoli	41,198	Christopher S. Chow	46,493
Mark J. Thronson	33,082	Brian A. Lemm	43,748		

and also, attorneys of Micron Technology, Inc. as its attorneys with full power of substitution to prosecute this application and to transact all business in the Patent and Trademark Office in connection therewith.


The Assignee certifies that the above-identified assignment has been reviewed and to the best of the Assignee's knowledge and belief, title is in the assignee.

Please direct all correspondence regarding this application to the following:

Thomas J. D'Amico  
DICKSTEIN SHAPIRO MORIN & OSHINSKY LLP  
2101 L Street NW  
Washington, DC 20037-1526  
(202) 785-9700  
(202) 861-9106

Respectfully submitted,

MICRON TECHNOLOGY, INC.

  
\_\_\_\_\_  
Michael L. Lynch  
Chief Patent Counsel  
Registration No. 30,871

Dated: 11/27/00

**COPY**

100-443887-11

We hereby consent that a copy of this assignment shall be deemed a full legal and formal equivalent of any document which may be required in any country in proof of the right of Micron Technology, Inc. to apply for patent or other form of protection for said inventions and to claim the aforesaid benefit of the right of priority.

We request that any and all patents for said inventions be issued to Micron Technology, Inc. in the United States and in all countries foreign to the United States, or to such nominees as Micron Technology, Inc. may designate.

**COPY**

We agree that, when requested, we shall, without charge to Micron Technology, Inc. but at its expense, sign all papers, and do all acts which may be necessary, desirable or convenient in connection with said applications, patents, or other forms of protection.

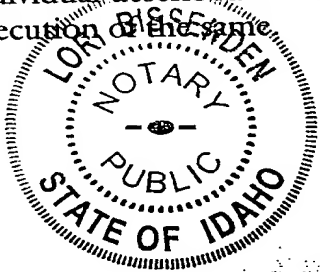
Gurtej Sandhu

Date: 11/15/00

United States of America )  
State Idaho )ss.:  
County Ada )

On this 15<sup>th</sup> day of November, 2000, before me personally came Gurtej Sandhu, to me known to be the individual described in and who executed the foregoing instrument, and acknowledged execution of the same.

J. Sri Puspendu  
Notary Public




IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ASSIGNMENT AND AGREEMENT

Signature Page for Second Inventor

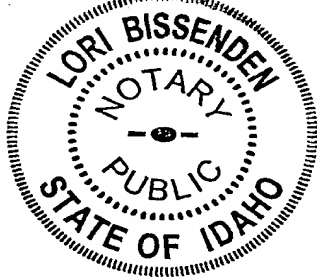
COPY

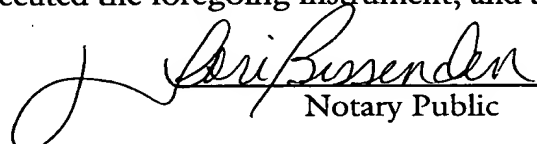
  
\_\_\_\_\_  
Trung T. Doan

Date: 11-20-00

United States of America )  
State Idaho )ss.:  
County Ada )

On this 20<sup>th</sup> day of November, 2000, before me  
personally came Trung T. Doan, to me known to be the  
individual described in and who executed the foregoing instrument, and acknowledged  
execution of the same.



  
\_\_\_\_\_  
Notary Public

11-20-00 11:36:56